

L Number	Hits	Search Text	DB	Time stamp
-	1	("6381025").PN.	USPAT; US-PGPUB	2003/06/18 12:38
-	1	("5325170").PN.	USPAT; US-PGPUB	2003/06/18 12:37
-	0	6381025.URPN.	USPAT	2003/06/18 12:37
-	44	(356/481).CCLS.	USPAT; US-PGPUB	2003/06/18 12:38
-	178	(356/517).CCLS.	USPAT; US-PGPUB	2003/06/18 13:36
-	4	5325170.URPN.	USPAT	2003/06/18 13:22
-	504734	interfer or interfere or interfering or interference or interferometer or interferometric or interferometrically	USPAT; US-PGPUB	2003/06/18 14:06
-	68534	refractive adj (index or indexing)	USPAT; US-PGPUB	2003/06/18 14:07
-	646931	substrate or mask or wafer	USPAT; US-PGPUB	2003/06/18 14:07
-	4033	backscatter or (back adj scatter)	USPAT; US-PGPUB	2003/06/18 14:07
-	23338	(interfer or interfere or interfering or interference or interferometer or interferometric or interferometrically) and (refractive adj (index or indexing))	USPAT; US-PGPUB	2003/06/18 13:38
-	270	((interfer or interfere or interfering or interference or interferometer or interferometric or interferometrically) and (refractive adj (index or indexing))) and (backscatter or (back adj scatter))	USPAT; US-PGPUB	2003/06/18 13:38
-	121	((((interfer or interfere or interfering or interference or interferometer or interferometric or interferometrically) and (refractive adj (index or indexing))) and (backscatter or (back adj scatter))) and (substrate or mask or wafer))	USPAT; US-PGPUB	2003/06/18 13:38
-	68670	interfer or interfere or interfering or interference or interferometer or interferometric or interferometrically	EPO; JPO; IBM_TDB	2003/06/18 14:06
-	33672	refractive adj (index or indexing)	EPO; JPO; IBM_TDB	2003/06/18 14:07
-	613256	substrate or mask or wafer	EPO; JPO; IBM_TDB	2003/06/18 14:07
-	243	backscatter or (back adj scatter)	EPO; JPO; IBM_TDB	2003/06/18 14:07
-	9384	(refractive adj (index or indexing)) and (substrate or mask or wafer)	EPO; JPO; IBM_TDB	2003/06/18 14:07
-	0	((refractive adj (index or indexing)) and (substrate or mask or wafer)) and (backscatter or (back adj scatter))	EPO; JPO; IBM_TDB	2003/06/18 14:07
-	9384	((refractive adj (index or indexing)) and (substrate or mask or wafer)) and (substrate or mask or wafer)	EPO; JPO; IBM_TDB	2003/06/18 14:07
-	618	((refractive adj (index or indexing)) and (substrate or mask or wafer)) and (interfer or interfere or interfering or interference or interferometer or interferometric or interferometrically)	EPO; JPO; IBM_TDB	2003/06/18 14:08
-	0	((((refractive adj (index or indexing)) and (substrate or mask or wafer)) and (interfer or interfere or interfering or interference or interferometer or interferometric or interferometrically)) and (backscatter or (back adj scatter)))	USPAT; US-PGPUB	2003/06/18 14:08